

# Radiation characterization of two large and fully depleted CMOS pixel matrices fabricated in 150 nm and 180 nm technologies

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Two different design concepts of the depleted monolithic CMOS active sensor (DMAPS) are realized in the large scale pixel matrixes, named LF-Monopix and TJ-Monopix. They are realized in so-called large and small electrode design in a pixel. In the large electrode DMAPS, a high bias voltage of 300 V is applied to the highly resistive wafer without damaging the readout electronics. Full depletion of the sensor was observed at 20 V and at 120 V for 100  $\mu\text{m}$  or 200  $\mu\text{m}$  thinned wafer, respectively. In contrast, the small fill factor DMAPS has analog front end circuit that achieves low noise (19 e-) and low power (110 mW/cm<sup>2</sup>) thanks to its small detector capacitance. The sensing volume is modified 25  $\mu\text{m}$  p-epi layer, and it is also fully depleted. Both of prototypes are fully monolithic DMAPS equipped with a fast readout in column drain architecture. To investigate the radiation hardness of both pixel matrixes, they are irradiated with neutrons and protons up to the fluence of  $1 \times 10^{15} \text{n}_{eq}/\text{cm}^2$ . Results of electrical and beam tests performed on un-irradiated and irradiated chips will be shown in this presentation.

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